

PATENT  
Docket No.: MAN-013

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Hu, Shouxiang

Serial No.: 10/723,285

Filed: November 25, 2003

In re Application of: Werner et al.

For: SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR STRUCTURE

## Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 12/5/05.

Signed Krista Thompson  
Krista Thompson

## TRANSMITTAL LETTER

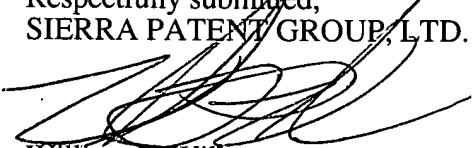
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Dear Sir:

Enclosed please find a Response to the Office Action dated July 5, 2005, Figure 7 and Figure 8, a Request for Two Months Extension of Time and a check in the amount of \$225.00 for the Request for Extension of Time in connection with the above-identified application.

In the event the Patent Office charges a fee for filing the above-noted documents, including any fees required under 37 CFR 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, the Assistant Commissioner is hereby authorized to charge or credit the difference to our Deposit Account No. 50-0612. An additional copy of this page is enclosed.

Respectfully submitted,  
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Dated: December 5, 2005

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